

FORM PTO-1449
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.: ST 9940

SERIAL NO.

LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

APPLICANT: Siebert et al.

FILING DATE:

GROUP:

14886 U.S. PTO
09/11/98

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
SL	AL	0711 854	5/15/96	Europe				
	AM	0684 634	11/29/95	Europe				
	AN	199 05 737	8/31/00	Germany				
SL	AO	198 33 257	9/30/99	Germany				
	AP							

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

SL	AR		English Derwent Abstract AN 2000-579981 [55]
			corresp. to DE 199 05 737
SL	AS		English Derwent Abstract AN 1999 519699 [44]
			corresp. to DE 198 33 257
SL	AT		H.M. Liaw, J.W. Rose, Epitaxial Silicon Technology,
			Academic Press Inc., Orlando, Florida, 1986, p. 71-73

EXAMINER

DATE CONSIDERED

5/02/2002

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.